Attorney's Docket No.: 07977-213002 Client's Ref. No.: US3521/3522



OFFICIAL COMMUNICATION

FACSIMILE

FOR THE PERSONAL ATTENTION OF:

EXAMINER-JOSE R. DIAZ

GROUP 2815 FAX NO: (703) 872-9318

FAX COPY RECEIVED

Number of pages including this page 27

OCT 17 2002

TECHNOLOGY CENTER 2800

Applicant: Ohtani, et al.

Art Unit : 2815

Serial No.: 09/455,991 Filed: December 6, 1999 Examiner: Jose R. Diaz Confirmation No.: 5835

FACSIMILE COMMUNICATION

Title

: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE

SAME

Commissioner for Patents Washington, D.C. 20231

Sir:

Attached to this facsimile communication cover sheet is an Amendment, faxed this 17th day of October, 2002, to Group 2815, the United States Patent and Trademark Office.

Respectfully submitted,

Date: October 17, 2002

Scott C. Harris/5MR Reg. No. 32,030

PTO Customer No. 20985

Fish & Richardson P.C. 4350 La Jolla Village Drive, Suite 500 San Diego, California 92122

Telephone: (858) 678-5070

Fax: (858) 678-5099

10222773.doc

NOTE: This facsimile is intended for the addressee only and may contain privileged or confidential information. If you have received this facsimile in error, please immediately call us collect at (858) 678-5070 to arrange for its return. Thank you.

Attorney's Docket No.: 07977/213002/US3521/3522

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ohtani, et al.

Art Unit : 2815

Serial No.: 09/455,991

Examiner : Jose R. Diaz

Filed

: December 6, 1999

Confirmation No.: 5835

Title

: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE

SAME

Commissioner for Patents Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Official Action dated June 17, 2002, Paper No. 12, in the above-referenced application, kindly amend the above-identified application as follows.

In the Claims:

Please cancel claims 17, 19, and 22 without prejudice.

10/29/2002 CHRLES 00000002 061050 0945599t he claims as follows.

110.00 CH 756.00 CH 01 FL:12%

420.00 CH 6.

(Amended) A method of manufacturing a semiconductor

device, said method comprising:

forming an amorphous semiconductor film on an insulating

surface;

CERTIFICATE OF TRANSMISSION BY FACSIMILE

I hereby certify that this correspondence is being transmitted by facsimile to the Patent and Trademark Office on the date indicated below.

October 17, 2002

Date of Transmission

Signature

Susan Regan Typed or Printed Name of Person Signing Certificate